



## Ri Hu Hwang

Patent Attorney

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Ms. Ri Hu Hwang is a patent attorney in the Intellectual Property Practice Group at Shin & Kim, where her primary areas of practice include the filing and prosecution of patents related to displays, electronics, and information and communications technology (ICT).

She previously worked at a patent law firm, where she handled domestic and international patent applications in the electronics and IT fields, responded to office actions, and managed PCT international applications.

## Professional Career

|              |                        |
|--------------|------------------------|
| 2026-Present | Shin & Kim LLC         |
| 2025-2026    | DANA Patent & Law Firm |

## Education

|           |                                     |
|-----------|-------------------------------------|
| 2010-2017 | Yonsei University (B.S. in Physics) |
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## Qualifications

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| 2024 | Admitted to patent bar, Korea |
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# Languages

Korean, English

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